

<b>Notice of References Cited</b>	Application/Control No. 09/873,664	Applicant(s)/Patent Under Reexamination HOWALD ET AL.	
	Examiner Blaise L Mouttet	Art Unit 2853	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-4587202	05-1986	Borysko	430/320
	C	US-4943719	07-1990	Akamine et al.	250/306
	D	US-5057401	10-1991	Borysko et al.	430/320
	E	US-5239863	08-1993	Kado et al.	73/105
	F	US-5253515	10-1993	Toda et al.	73/105
	G	US-5587090	12-1996	Belcher et al.	216/17
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**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Gregory Kovacs, Micromachined Transducers Sourcebook, 1998, McGraw-Hill, pgs 146-148 ✓
	V	Nadim Maluf, An Introduction to Microelectromechanical Engineering, 2000, Artech House, pgs. 192-196 ✓
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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